

Surface Mount Micromachined Accelerometer

The MMA series of silicon capacitive, micromachined accelerometers feature signal conditioning, a 4-pole low pass filter and temperature compensation. Zero-g offset full scale span and filter cut-off are factory set and require no external devices. A full system self-test capability verifies system functionality.

Features

- Integral Signal Conditioning
- Linear Output
- Ratiometric Performance
- 4th Order Bessel Filter Preserves Pulse Shape Integrity
- Calibrated Self-test
- Low Voltage Detect, Clock Monitor, and EPROM Parity Check Status
- Transducer Hermetically Sealed at Wafer Level for Superior Reliability
- Robust Design, High Shocks Survivability

Typical Applications

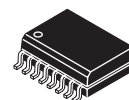
- Vibration Monitoring and Recording
- Impact Monitoring

ORDERING INFORMATION

Device Name	Temperature Range	Case No.	Package
MMA2301D	-40° to 125°C	475-01	SOIC-16
MMA2301DR2	-40° to 125°C	475-01	SOIC16, Tape & Reel
MMA2301EG	-40° to 125°C	475-01	SOIC-16
MMA2301EGR2	-40° to 125°C	475-01	SOIC-16, Tape & Reel

MMA2301

**MMA2301D: X-AXIS SENSITIVITY
MICROMACHINED
ACCELEROMETER
±200G**



**D SUFFIX
EG SUFFIX (Pb-FREE)
16-LEAD SOIC
CASE 475-01**

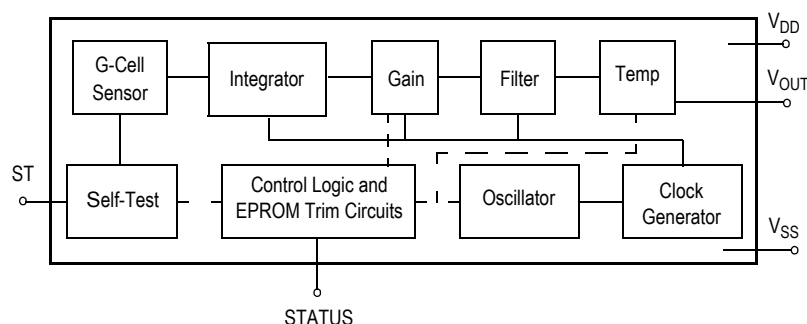


Table 1. Maximum Ratings

(Maximum ratings are the limits to which the device can be exposed without causing permanent damage.)

Rating	Symbol	Value	Unit
Powered Acceleration (all axes)	G_{pd}	1500	g
Unpowered Acceleration (all axes)	G_{upd}	2000	g
Supply Voltage	V_{DD}	−0.3 to +7.0	V
Drop Test ⁽¹⁾	D_{drop}	1.2	m
Storage Temperature Range	T_{stg}	−40 to +125	°C

1. Dropped onto concrete surface from any axis.

ELECTRO STATIC DISCHARGE (ESD)

WARNING: This device is sensitive to electrostatic discharge.

Although the accelerometers contain internal 2 kV ESD protection circuitry, extra precaution must be taken by the user to protect the chip from ESD. A charge of over 2000 volts can accumulate on the human body or associated test equipment. A charge of this magnitude can alter the

performance or cause failure of the chip. When handling the accelerometer, proper ESD precautions should be followed to avoid exposing the device to discharges which may be detrimental to its performance.

Table 2. Operating Characteristics(Unless otherwise noted: $-40^{\circ}\text{C} \leq T_A \leq +105^{\circ}\text{C}$, $4.75 \leq V_{DD} \leq 5.25$, Acceleration = 0g, Loaded output)⁽¹⁾

Characteristic	Symbol	Min	Typ	Max	Unit
Operating Range ⁽²⁾					
Supply Voltage ⁽³⁾	V_{DD}	4.75	5.0	5.25	V
Supply Current	I_{DD}	3.0	—	6.0	mA
Operating Temperature Range	T_A	-40	—	+125	$^{\circ}\text{C}$
Acceleration Range	g_{FS}	—	225	—	g
Output Signal					
Zero g ($T_A = 25^{\circ}\text{C}$, $V_{DD} = 5.0\text{ V}$) ⁽⁴⁾	V_{OFF}	2.4	2.5	2.6	V
Zero g	$V_{OFF,V}$	$0.46 V_{DD}$	$0.50 V_{DD}$	$0.54 V_{DD}$	V
Sensitivity ($T_A = 25^{\circ}\text{C}$, $V_{DD} = 5.0\text{ V}$) ⁽⁵⁾	S	9.5	10.0	10.5	mV/g
Sensitivity	S_V	1.86	2.0	2.14	mV/g/V
Bandwidth Response	f_{-3dB}	360	400	440	Hz
Nonlinearity	NL_{OUT}	-1.0	—	1.0	% FSO
Noise					
RMS (.01-1 kHz)	n_{RMS}	—	—	2.8	mVrms
Power Spectral Density	n_{PSD}	—	110	—	$\mu\text{V}/(\text{Hz}^{1/2})$
Clock Noise (without RC load on output) ⁽⁶⁾	n_{CLK}	—	2.0	—	mVpk
Self-Test					
Output Response	g_{ST}	24	30	36	g
Input Low	V_{IL}				

PRINCIPLE OF OPERATION

The Freescale Semiconductor, Inc. accelerometer is a surface-micromachined integrated-circuit accelerometer.

The device consists of a surface micromachined capacitive sensing cell (g-cell) and a CMOS signal conditioning ASIC contained in a single integrated circuit package. The sensing element is sealed hermetically at the wafer level using a bulk micromachined *cap* wafer.

The g-cell is a mechanical structure formed from semiconductor materials (polysilicon) using semiconductor processes (masking and etching). It can be modeled as a set of beams attached to a movable central mass that move between fixed beams. The movable beams can be deflected from their rest position by subjecting the system to an acceleration([Figure 3](#)).

As the beams attached to the central mass move, the distance from them to the fixed beams on one side will increase by the same amount that the distance to the fixed beams on the other side decreases. The change in distance is a measure of acceleration.

The g-cell plates form two back-to-back capacitors ([Figure 3](#)). As the central mass moves with acceleration, the distance between the beams change and each capacitor's value will change, ($C = NA\epsilon/D$). Where A is the area of the

facing side of the beam, ϵ is the dielectric constant, D is the distance between the beams, and N is the number of beams.

The CMOS ASIC uses switched capacitor techniques to measure the g-cell capacitors and extract the acceleration data from the difference between the two capacitors. The ASIC also signal conditions and filters (switched capacitor) the signal, providing a high level output voltage that is ratiometric and proportional to acceleration.

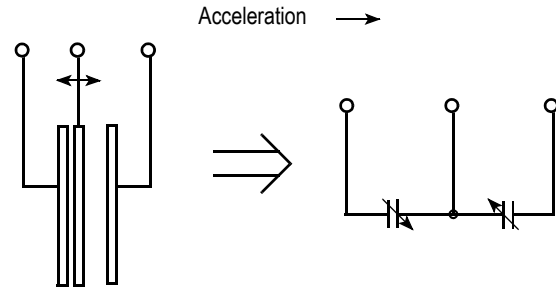


Figure 3. Simplified Transducer Physical Model versus Transducer Physical Model

SPECIAL FEATURES

Filtering

The accelerometers contain an onboard 4-pole switched capacitor filter. A Bessel implementation is used because it provides a maximally flat delay response (linear phase) thus preserving pulse shape integrity. Because the filter is realized using switched capacitor techniques, there is no requirement for external passive components (resistors and capacitors) to set the cut-off frequency.

Self-Test

The sensor provides a

BASIC CONNECTIONS

PINOUT DESCRIPTION

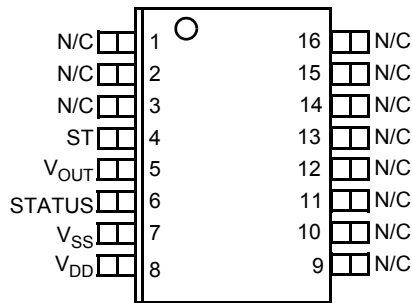


Table 3. Pin Descriptions

Pin No.	Pin Name	Description
1 thru 3	N/C	Leave unconnected.
4	ST	Logic input pin used to initiate self-test.
5	V _{OUT}	Output voltage of the accelerometer.
6	STATUS	Logic output pin to indicate fault.
7	V _{SS}	The power supply ground.
8	V _{DD}	The power supply input.
9 thru 13	Trim pins	Used for factory trim. Leave unconnected.
14 thru 16	—	No internal connection. Leave unconnected.

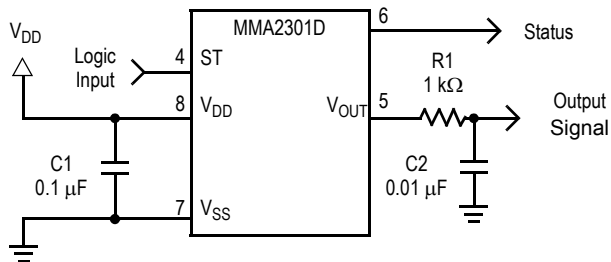


Figure 4. SOIC Accelerometer with Recommended Connection Diagram

PCB Layout

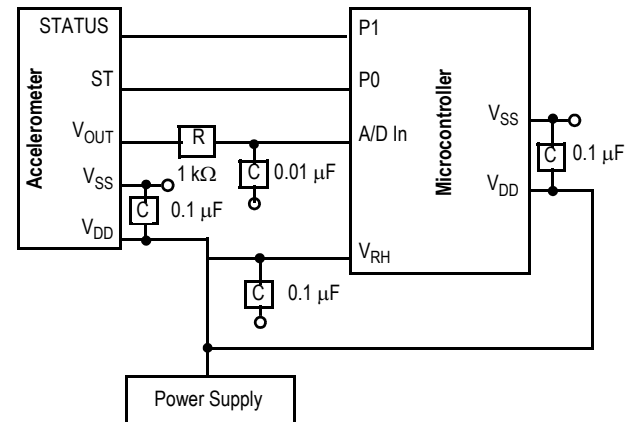
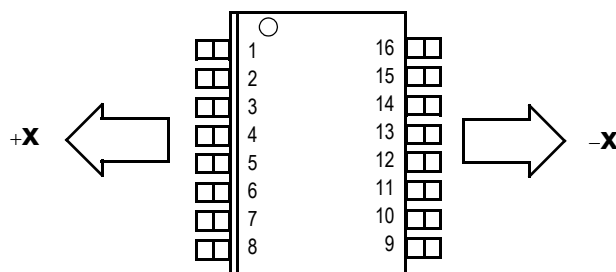


Figure 5. Recommend PCB Layout for Interfacing Accelerometer to Microcontroller

Dynamic Acceleration Sensing Direction

Acceleration of the package in the +X direction (center plate moves in the -X direction) will result in an increase in the output.

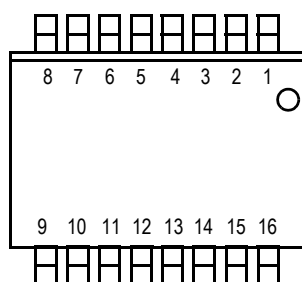


Activation of Self Test moves the center plate in the -X direction, resulting in an increase in the output.

16-Pin SOIC Package
N/C pins are recommended to be left FLOATING

Top View

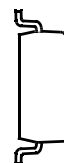
Static Acceleration Sensing Direction



Front View



Direction of Earth's gravity field.*



Side View

* When positioned as shown, the Earth's gravity will result in a positive 1g output.

MINIMUM RECOMMENDED FOOTPRINT FOR SURFACE MOUNTED APPLICATIONS

Surface mount board layout is a critical portion of the total design. The footprint for the surface mount packages must be the correct size to ensure proper solder connection interface between the board and the package. With the

correct footprint, the packages will self-align when subjected to a solder reflow process. It is always recommended to design boards with a solder mask layer to avoid bridging and shorting between solder pads.

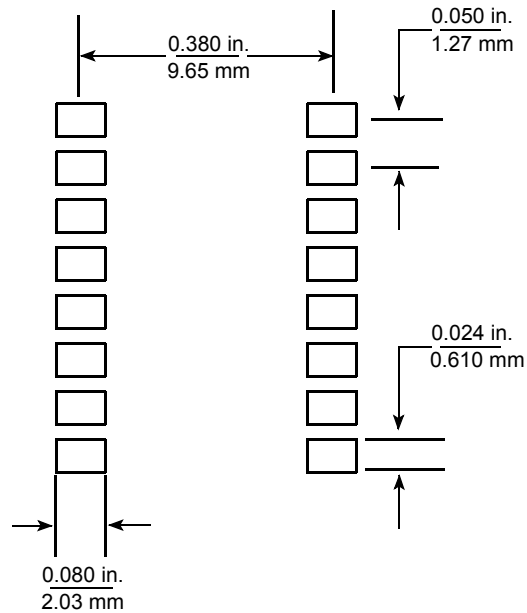
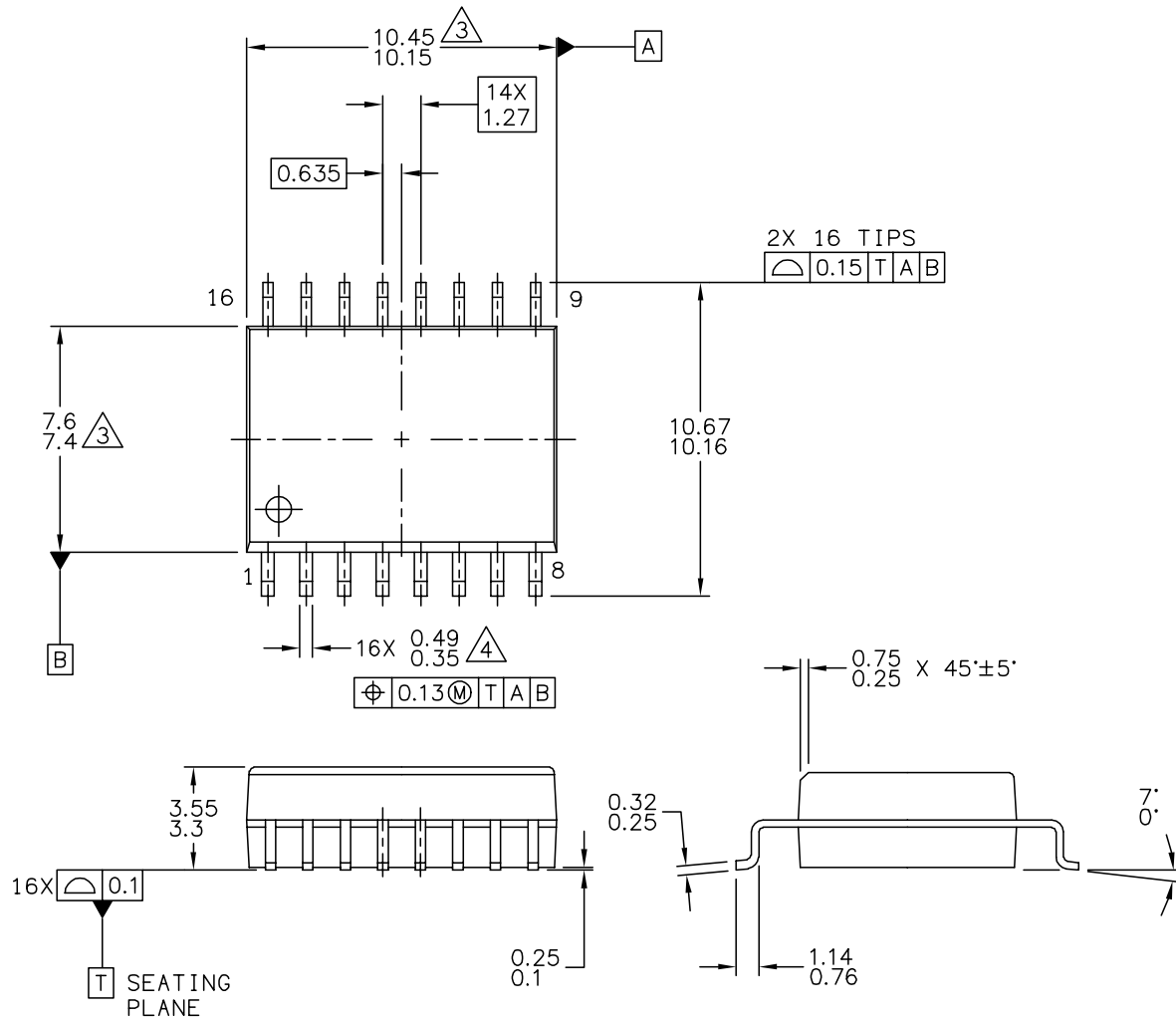


Figure 6. Footprint SOIC-16 (Case 475-01)

PACKAGE DIMENSIONS



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TITLE: 16 LEAD SOIC ACCELEROMETER	DOCUMENT NO: 98ASB16926C	REV: C
	CASE NUMBER: 475-01	17 MAR 2005
	STANDARD: NON-JEDEC	

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**CASE 475-01
ISSUE C
16-LEAD SOIC**

PACKAGE DIMENSIONS

NOTES:

1. ALL DIMENSIONS ARE IN MILLIMETERS.
2. INTERPRET DIMENSIONS AND TOLERANCES PER ASME Y14.5M-1994.
3. THESE DIMENSIONS DO NOT INCLUDE MOLD FLASH OR PROTRUSIONS. MOLD FLASH OR PROTRUSIONS SHALL NOT EXCEED 0.15 PER SIDE.
4. THIS DIMENSION DOES NOT INCLUDE DAMBAR PROTRUSION. PROTRUSIONS SHALL NOT CAUSE THE LEAD WIDTH TO EXCEED 0.75

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**CASE 475-01
ISSUE C
16-LEAD SOIC**

MMA2301D

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